

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 6, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG668412491

LABORATORY GROWN DIAMOND

EMERALD CUT

10.78 X 7.43 X 5.02 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.96 CARATS

G

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

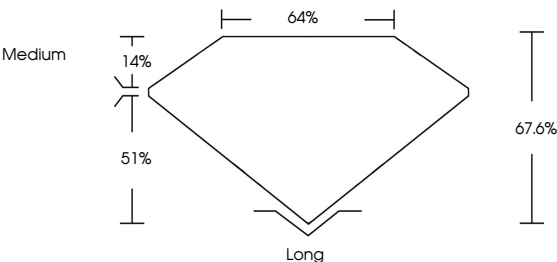
NONE

Inscription(s)

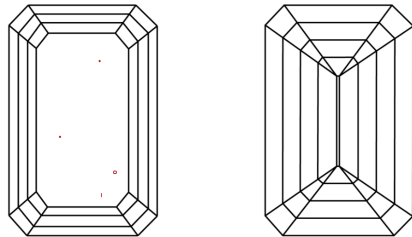
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG668412491

PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR



D E F G H I J

Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3


Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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
EXCELLENT


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IGI

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EMERALD CUT

10.78 X 7.43 X 5.02 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

3.96 CARATS

G

VS 1

67.6%

64%


Medium

Long

EXCELLENT

EXCELLENT

NONE

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